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Express Mail #EL613112157US

Asst. Commissioner for Patents
Washington, DC 20231

OFGS File No. : P/2292-43
Inventor : Ki Young OH et al
Title : APPARATUS AND METHOD FOR FORMING ULTRA-THIN FILM
OF SEMICONDUCTOR DEVICE
Assignee : Jusung Engineering Co., Ltd.

Enclosed herewith please find the following documents in the above-identified
application for United States Letters Patent:

Print EFS Data Sheet
 22 Pages of Specification including Abstract and Claims
 11 Numbered Claims Calculated as 11 Claims for Fee Purposes
 4 Sheets of Drawing Containing Figures 1 to 6. (Formal)
 X Declaration and Power of Attorney
 X Priority is Claimed under 35 U.S.C. §119:
Convention Date April 18, 2000 for Korea Appln. S.N. 20239/2000
 X Certified Priority Application
 X Small Entity Status is claimed.
 X Assignment
 X Return-Addressed Post Card
OFGS Check No. 4227, which includes the fee of \$395.00, calculated as follows:
Basic Filing Fee: \$ 710.00
Additional Filing Fees:
Total Number of Claims in Excess of 20, times \$18:
Number of Independent Claims in Excess of 3, times \$80:
One or More Multiple Dependent Claims: Total \$270.
Total Filing Fees or
Total Filing Fee Reduced 50% for Small Entity: 355.00
Assignment Recording Fee: \$40 40.00
TOTAL Filing Fee and Assignment Recording Fee: \$ 395.00

In the event the actual fee is greater than the payment submitted or is
inadvertently not enclosed, or if any additional fee during the prosecution of
this case is not paid, the Patent and Trademark Office is authorized to charge
the underpayment to Deposit Account No. 15-0700.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee (mail label #EL613112157US) in an envelope addressed to: Asst. Commissioner for Patents, Washington, D.C. 20231, on April 16, 2001:

Dorothy Jenkins

Name of Person Mailing Correspondence

Dorothy Jenkins
Signature
April 16, 2001
Date of Signature

Respectfully submitted,

Max Moskowitz

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APPLICATION INFORMATION

Title Line One:: Apparatus And Method For Forming Ultra-T
Title Line Two:: hin Film Of Semiconductor Device
Total Drawing Sheets:: 4
Formal Drawings?:: Yes
Application Type:: Utility
Docket Number:: P/2292-43
Secrecy Order in Parent Appl.?:: No

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 20239/2000
Filing Date:: 04-18-2000
Country:: Korea
Priority Claimed:: Yes

Source:: PrintEFS Version 1.0.1